

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 6, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG806623088

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

8.82 - 8.88 X 5.28 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

2.55 CARATS

G

VS 1

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

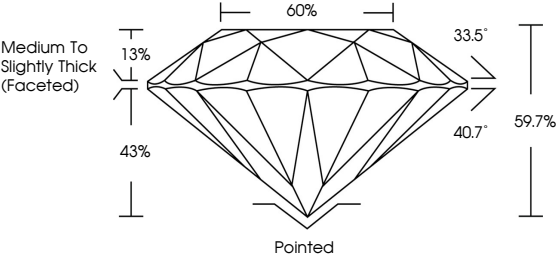
EXCELLENT

NONE

 LG806623088

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

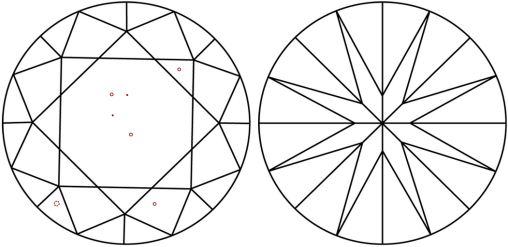
PROPORTIONS



Medium To Slightly Thick (Faceted)

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

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Polish

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Inscription(s)

EXCELLENT

EXCELLENT

NONE

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IGI Report No LG806623088

ROUND BRILLIANT

8.82 - 8.88 X 5.28 MM

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

2.55 CARATS

G

VS 1

IDEAL

60%

60%

EXCELLENT

EXCELLENT

NONE

 LG806623088

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Type IIa